



Docket No.: M4065.0319/P319-A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Husam N. Al-Shareef, et al.

Examiner: Erik Kielin

Application No.: 09/912,558

Art Unit: 2813 ✓

Filed: July 26, 2001

For: FABRICATION OF DRAM AND OTHER
SEMICONDUCTOR DEVICES WITH AN
INSULATING FILM USING A WET
RAPID THERMAL OXIDATION PROCESS

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RESPONSE TO RESTRICTION REQUIREMENT

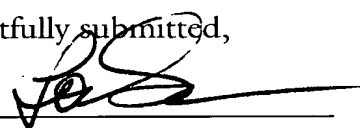
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement set forth in the Office Action dated December 19, 2003, Applicants elect Group I, claims 13, 14, 16, 17 and 42, for continued examination. This election is made without traverse. An action on the merits of all the claims and a Notice of Allowance thereof are respectfully requested.

Dated: January 6, 2004
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Respectfully submitted,

By 
Thomas J. D'Amico
Registration No.: 28,371
DICKSTEIN SHAPIRO MORIN &
OSHINSKY LLP
2101 L Street NW
Washington, DC 20037-1526
(202) 785-9700
Attorney for Applicants